

Application Data Sheet

Application Information

Application number::	Not Yet Assigned
Application Type::	Regular
Subject Matter::	Utility
Suggested Group Art Unit::	N/A
CD-ROM or CD-R?::	None
Sequence submission?::	None
Computer Readable Form (CRF)?::	No
Title::	METHOD AND APPARATUS FOR ORIENTING SEMICONDUCTOR WAFERS IN SEMICONDUCTOR FABRICATION
Attorney Docket Number::	543822004600
Request for Early Publication?::	No
Request for Non-Publication?::	No
Small Entity?::	No
Petition included?::	No
Secrecy Order in Parent Appl.?::	No

Applicant Information

Applicant Authority Type::	Inventor
Primary Citizenship Country::	Germany
Status::	Full Capacity
Given Name::	Jens
Family Name::	STÄCKER
City of Residence::	Dresden
Country of Residence::	Germany
Street of mailing address::	Hauptstrasse 13
City of mailing address::	Dresden
Country of mailing address::	Germany
Postal or Zip Code of mailing address::	D-01097

Correspondence Information

Correspondence Customer Number:: 25227

Representative Information

Representative Customer Number:: 25227

Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
Germany	10315086.2	April 2, 2003	Yes

Assignee Information

Assignee name:: Infineon Technologies AG
Street of mailing address:: St.-Martin Strasse 53
City of mailing address:: Munich
Country of mailing address:: Germany
Postal or Zip Code of mailing address:: 81669